

Docket No.: 052775-0024



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
: Confirmation Number: 1716
Masahiro NAKAYAMA, et al. :
: Group Art Unit: 3723
Application No.: 10/662,524 :
: Examiner: Dung V. Nguyen
Filed: September 16, 2003 :
:

For: CHAMFERED FREESTANDING NITRIDE SEMICONDUCTOR WAFER AND
METHOD OF CHAMFERING NITRIDE SEMICONDUCTOR WAFER

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following Amendment and Remarks are submitted in response to the non-final
Office Action dated March 15, 2006.

Amendments to the Claims begin on page 2.

Remarks begin on page 5.